

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	) Confirmation No.: 9428
Shunpei <b>YAMAZAKI</b> , et al.	)
Serial No. 10/678,139	) Examiner: Mary A. Wilczewski
Filed: October 6, 2003	) Group Art Unit: 2822
For: METHOD FOR FABRICATING SEMICONDUCTOR THIN FILM	)

**AMENDMENT UNDER 37 C.F.R. § 1.114**

**Mail Stop AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated October 22, 2010, please consider Applicants' remarks as follows.

**Amendments to the Specification** begin on page 2 of this paper.

**A Listing of the Claims** begin on page 3 of this paper.

**Remarks** begin on page 8 of this paper.